



Atty. Dkt. No. AMAT/3840/CMP/ECP/RKK

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Original Application of:  
Cheung, et al.

Serial No.: 09/882,208

Confirmation No.: 8450

Filed: June 13, 2001

**For: Method and Apparatus for Conditioning Electrochemical Baths Used in Plating Technology**

Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Group Art Unit: 1742

Examiner: Wesley A. Nicolas

**CERTIFICATE OF MAILING**  
**37 CFR 1.8**

I hereby certify that this correspondence is being deposited on September 12, 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Non-Free Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

9/12/03  
Date

Signature

**RESPONSE TO OFFICE ACTION DATED JUNE 12, 2003**

In response to the Office Action dated June 12, 2003, having a shortened statutory period for response set to expire on September 12, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/3840/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

**Amendments to the Specification** begin on page 2 of the paper. **Amendments to the Claims** are reflected in the listing of claims which begins on page 3 of this paper. **Remarks/Arguments** begin on page 15 of this paper.